



520.36911CX2

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. ONO, et al

**RECEIVED**

Serial No.: 09/249,292

**DEC 23 2003**

Filed: February 12, 1999

**TC 1700**

For: METHOD AND APPARATUS FOR TREATING SURFACE OF SEMICONDUCTOR

Group: 1763

Examiner: A. Olsen

**AMENDMENT**

Mail Stop Fee-Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 15, 2003

Sir:

In response to the Office Action August 15, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.